

HOXON[®]

CLEAN SURFACE TECHNOLOGIES



WAFER CLEANING
INORGANIC OXIDATION
ORGANIC OXIDATION
PHOTORESIST REMOVAL
WATER DISINFECTION
BIOFILM ELIMINATION
CVD APPLICATIONS





HOXON[®]

CLEAN SURFACE TECHNOLOGIES

HOXON[®] clean surface technologies developed by Anseros, are putting new paradigm in semiconductor industry. HOXON systems[®] are based on green technologies which assured total ecological protection and collateral human safety.

We believe in Mother nature principles and integrating it with demanding clean surface applications. Environment and human fortification are the key segments of our business strategy.

We have a long history of successful and well established systems which are fueling semiconductor industry for more then 25 years. You named it and we already have a solution for you. Please feel free to have friendly chat with one of our R&D guy and explore what we can do for you.

Please see below some examples out of our range of applications:

- + Wafer cleaning, UCT-Process
- + Inorganic oxidation
- + Photoresist removal
- + Disinfection of DI-Water
- + In-Situ biofilm destruction
- + CVD applications
- + Off gas treatment
- + Waste water treatment
- + Sterilized climate areas

Physical characteristics:

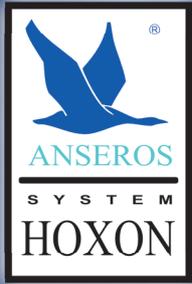
- + Fully metal-free systems
- + Gas phase up to $270 \text{ g O}_3 / \text{Nm}^3$
- + Liquid phase up to $100 \text{ g O}_3 / \text{m}^3$
- + AOP (Advanced Oxidation Process) cleanliness



LEGEND:

- Ozone Analyzer WM
- Ozone Generator COM-AD-08
- Safety Controller SEN-K
- AOPR Pipe Reactor
- Siemens S7 Controller

ANSEROS HOXON[®] SYSTEM PAP-SC-200



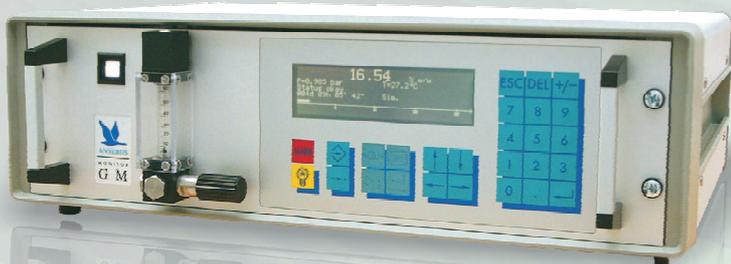
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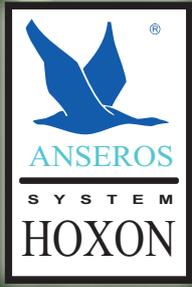
OZONE GENERATOR COM-AD-08

COM-AD-08 ozone generator is the heart of HOXON system. Sustainable metal free ozone generation which give pulse to mission critical applications.



OZONE ANALYZER GM-PRO

Total metal free equipment which maximizes shield against any metal contamination and assured accurate analysis.



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OZONE WATER SYSTEM PAP mobile

Mobile PAP system for in-situ sanitization of water networks, biofilm destruction, control of

OZONE DESTRUCTOR CAT-HO-8000

Ozone destruction in off gases containing vapor of acids along with high flow and pressure control. This system can also protect tools from metal particles. Thermo catalytic principle, patented.

Liquid version also available for ozonated



OZONE SENSOR SEN 6060-S

Safety sensors referring semiconductor standards (S2, S8).

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